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Bib Data Sheet

CONFIRMATION NO. 8214

SERIAL NUMBER 10/656,312	FILING DATE 09/05/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. TI-22398.1
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APPLICANTS

Sylvia H. Pas, Plano, TX;

** CONTINUING DATA *****

This application is a DIV of 09/758,610 01/11/2001 PAT 6,780,250

** FOREIGN APPLICATIONS ***** "NONE"

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/13/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	TX	2	7	1
Verified and Acknowledged	Examiner's Signature  Initials 				

ADDRESS

23494
 TEXAS INSTRUMENTS INCORPORATED
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TITLE

System and method for integrated oxide removal and processing of a semiconductor wafer

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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